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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Ronghua Wei et al.

Filed: March 26, 2004

For: METHOD AND APPARATUS FOR FORMING A NITRIDE LAYER ON A

BIOMEDICAL DEVICE

Serial No.: 10/811,485 Group Art Unit: 1762 Examiner: Unknown

Atty Dkt: SWRI:003

Pursuant to 37 C.F.R. 1.8, I certify that this correspondence is being deposited with the U.S. Postal Service in a first class, postage prepaid envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date below:

7-14-04

Date

Ollebrie Ferrara

ATTN: OFFICIAL DRAFTSMAN

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

SUBMISSION OF FORMAL DRAWINGS

Applicants hereby submit the formal drawings for the above-referenced application and request that these drawings be accepted for filing.

Respectfully submitted,

/Robert M. O'Keefe

Reg. No.: 35,630

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